Section "Biomolecules on nanoparticles and nanostructured surfaces"



FEMTOSECOND LASER PROCESSING OF TITANIUM DIOXIDE FILMS FOR PHOTOCATALYTIC AND SELF-CLEANING **APPLICATIONS**



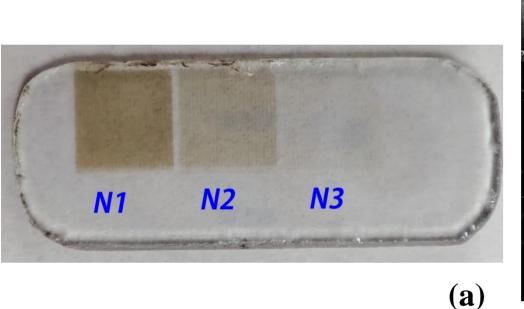
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Introduction Titanium dioxide (TiO₂) layers on various substrates are interesting for their self-cleaning and photocatalytic properties that are crucial for removing organic compounds of biological origin from optical elements operating in harsh environmental conditions. TiO₂ is of particular interest due to its multiple polytypes (brookite, anatase and rutile) which can transform into one another. We present the development of functional TiO₂ films on glass substrates and their subsequent processing with femtosecond laser radiation. The femtosecond laser treatment provides fast and reliable method for contactless modification of thin films. Laser treatment of TiO₂ films offers broad opportunities to tailor film characteristics such as thickness, crystalline or amorphous structure, grain size, residual stress, and defect density. [1]

Methods of the preparation and further treatment of TiO₂ films The TiO₂ sols have been synthesized using the sol-gel method. TiO₂ film preparation included applying a sol onto glass substrates using spin-coating method followed by drying and calcination at 450°C. Annealing regime was selected to improve film density and uniformity. Further modification was performed using ultrashort laser pulses generated by a Ti:sapphire laser system ($\lambda = 800$ nm, the pulse repetition frequency 1kHz, the pulse duration ~ 100 fs, scanning velocity 3 mm/s).

Results SEM analysis the 2TiO film on glass substrate reveals satisfactory uniformity of TiO₂ film (Fig. a, b), and moreover good dielectric properties.

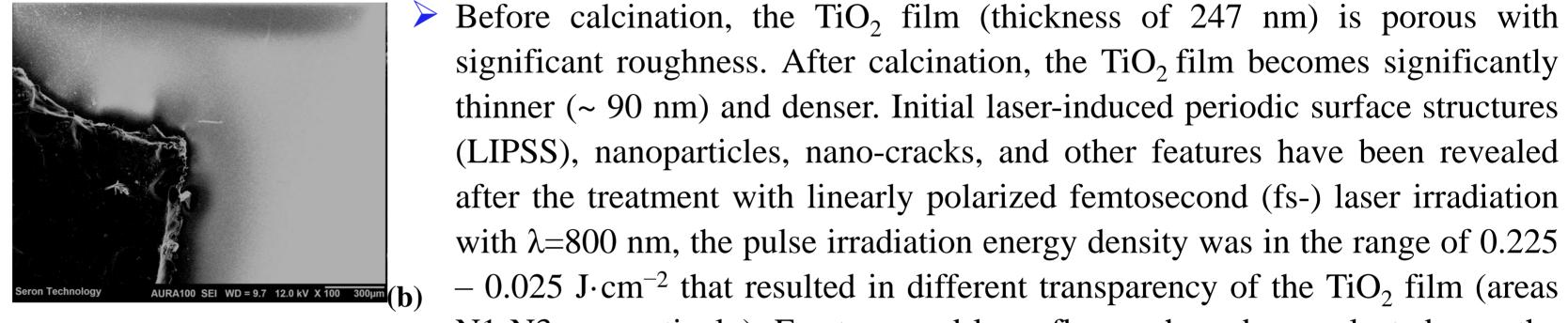


80 -

70

%

10 -



1.0220

1.0215

1.0210

1.0205

1.0200

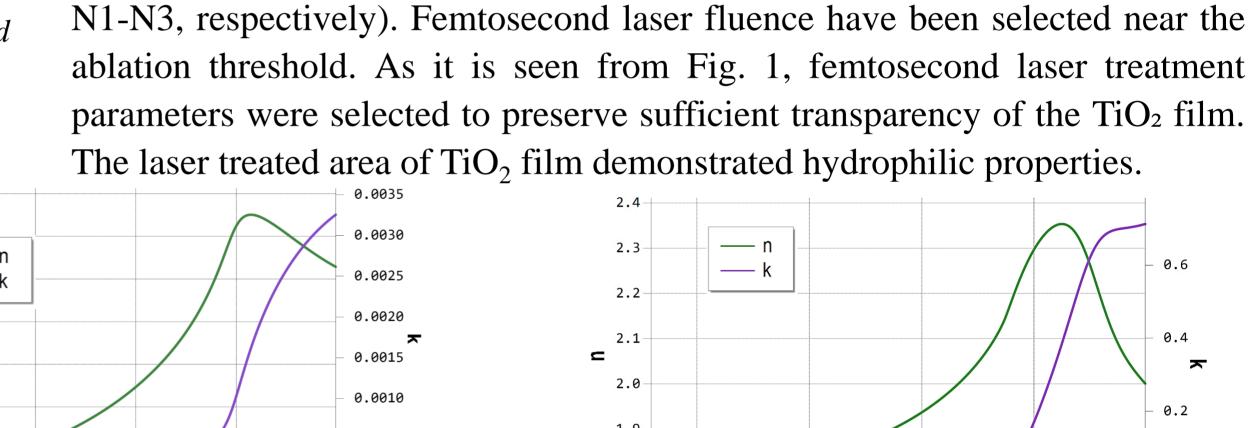
1.0195

1.0190

1.0185

(a)

Fig. 1. (a) View of the sample with TiO₂ film with marked areas treated with a femtosecond laser (fundamental wavelength 800 nm). (b) SEM image of the TiO_2 film.



0.0005

0.0000

(b)

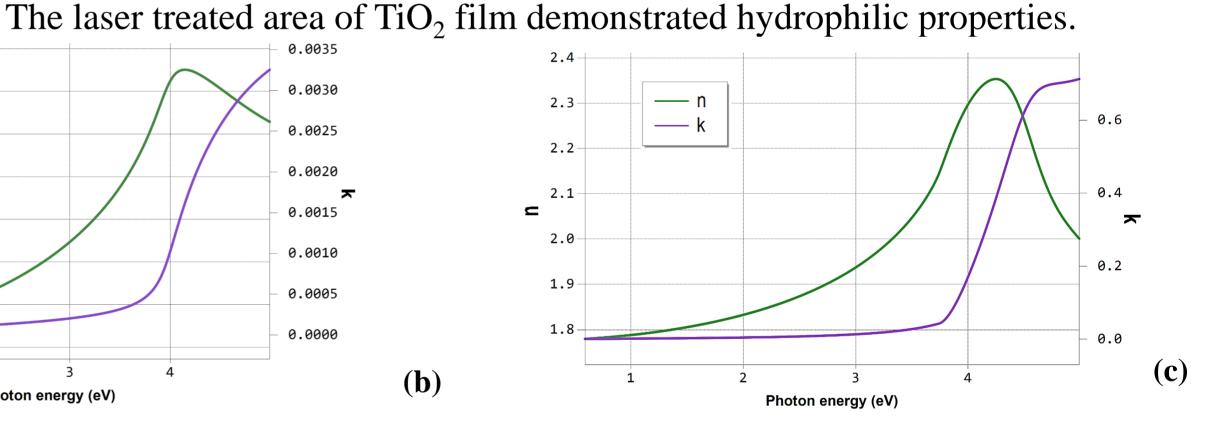
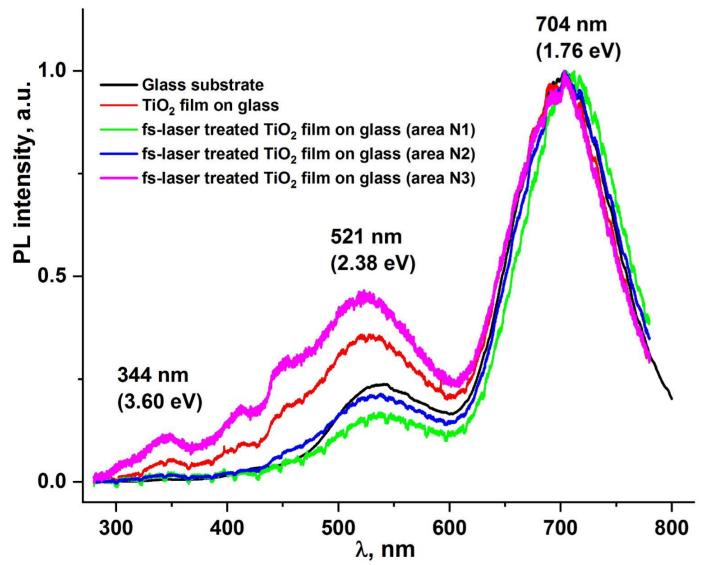


Fig. 2. (a) Transmittance of glass substrate and TiO₂ films after calcination at 450°C, (b) Spectral dependences of optical parameters of TiO2 films before (a) and after (c) calcination at 450°C.

The films exhibit a large energy band gap of 3.9 eV before calcination, which decreases slightly to 3.7 eV after calcination. Since no conducting component is detected, this band gap value for TiO2 may be due not to the Burstein-Moss effect, but to the quantum-size effect.

Photon energy (eV)



fs-laser treated area of TiO₂ film (after calcination)

1000

- TiO₂ film (after calcination)

Glass substrate

Fig. 3. PL spectra of glass substrate and TiO₂ films before and after laser treatment.

> Photoluminescence (PL) spectra have been studied for each regime of femtosecond laser treatment of TiO₂ films deposited on glass. PL intensity presents the recombination efficiency of photogenerated charges that is an important factor for photocatalytic efficiency of TiO₂ films. PL spectra of TiO₂ films (both as grown and laser-treated) contain some intense broad PL bands. Emission from the glass substrate contributes to PL of the samples, namely causing the appearance of bands at about 536 nm (2.31 eV), 704 nm (1.76 eV). Nature of PL bands related to TiO₂ films can be defined as follows: wide complex band at around 521 nm (2.38 eV) is associated with the transitions from shallow trap levels induced by the presence of the oxygen vacancies, and weak broad PL band at about 344 nm (3.6 eV) corresponds to recombination of free and bound excitons in TiO₂. The relative intensities of these bands depend significantly on the parameters of laser processing of TiO₂ films.

significant roughness. After calcination, the TiO₂ film becomes significantly

thinner (~ 90 nm) and denser. Initial laser-induced periodic surface structures

(LIPSS), nanoparticles, nano-cracks, and other features have been revealed

after the treatment with linearly polarized femtosecond (fs-) laser irradiation

with λ =800 nm, the pulse irradiation energy density was in the range of 0.225

- 0.025 J⋅cm⁻² that resulted in different transparency of the TiO₂ film (areas

CONCLUSIONS: The development of functional TiO₂ films on glass substrates and their subsequent processing with femtosecond laser radiation have been studied. We demonstrated the femtosecond laser treatment conditions that satisfactory preserved sufficient transparency of the TiO2 film that is perspective for the coating of optical elements of special devices. The transparent laser treated area of TiO₂ film demonstrated hydrophilic properties, and PL spectrum of TiO₂ film at the pulse irradiation energy density of 0.225 J·cm⁻² contains main features of PL spectrum of as-grown TiO2 film.

References: [1] A. Medvids, P. Onufrijevs, J. Kaupužs, R. Eglitis, J. Padgurskas, A. Zunda, H. Mimura, I. Skadins, S. Varnagiris, Opt. Laser Technol., 138, 106898 (2021). Acknowledgments: Authors appreciate funding from the National Research Foundation of Ukraine (Project No. 2025.06/0087 (Agreement No. 209/0087) "Nanostructured titanium dioxide films for coating of optical elements").

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